



#3 1/2 / 5-7-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TC 2000 MAIL ROOM

APPLICANT: DIANE M. LANDERS ET AL.)
SERIAL NUMBER: 10/002,678) Group Art Unit: NYA
FILED: October 24, 2001) Examiner: NYA
FOR: HORIZONTALLY STRUCTURED)
MANUFACTURING PROCESS)
MODELING FOR FIXTURES)
AND TOOLING)

Commissioner of Patents
Washington, D.C. 20231

LETTER

Dear Sir:

Applicant hereby brings to the Examiner's attention the following co-pending applications having potentially related subject matter:

(H-204044 / DE3-0075) Application U.S.S.N. 09/483,301, "Horizontally-Structured Manufacturing Process Modeling", filed January 14, 2000 by Pravin Khurana et al.

(DP-301245 / DE3-0025) Application U.S.S.N. 09/483,722, "Horizontally-Structured CAD/CAM Modeling", filed January 14, 2000 by Pravin Khurana et al.

(DP-304037 / DE3-0203) Application U.S.S.N. 10/033,163, "Enhancement to Horizontally Structured Manufacturing Process Modeling", filed October 24, 2001 by Diane M. Landers et al.

(DP-304036 / DE3-0204) Application U.S.S.N. 10/032,960, "Enhancement to Horizontally-Structured CAD/CAM Modeling", filed October 24, 2001 by Diane M. Landers et al.

(DP-304140 / DE3-0205) Application U.S.S.N. 10/001,748, "Horizontally-Structured CAD/CAM Modeling For Virtual Concurrent Product and Process Design", filed October 24, 2001 by Diane M. Landers et al.

(DP-304139 / DE3-0206) Application U.S.S.N. 10/033,162, "Horizontally-Structured Manufacturing Process Modeling For: Alternate Operations, Large Parts, and Charted Parts", filed October 24, 2001 by Diane M. Landers et al.

(DP-304136 / DE3-0208) Application U.S.S.N. 10/033,333, "Horizontally Structured CAD/CAM Modeling For Virtual Fixture and Tooling Processes", filed October 24, 2001 by Diane M. Landers et al.

(DP-301830 / DE3-0209) Application U.S.S.N. 10/075,804, "Automated Horizontally Structured Manufacturing Process Design Modeling", filed October 24, 2001 by Diane M. Landers et al.

(DP-306554 / DE3-0257) Application U.S.S.N. 10/032,959, "Horizontally Structured Process Modeling for Concurrent Product and Process Design", filed October 24, 2001 by Diane M. Landers et al.

(DP-305592 / DE3-0248) Application U.S.S.N. 10/142,709, "System and Method for Integrating Geometric Models", filed May 10, 2002 by Ravikiran Duggirala.

(DP-306725 – DE3-0274) Application U.S.S.N. 60/375,621, "Method for Virtual Inspection of Virtually Machined Parts", filed April 26, 2002 by Steven Thomas et al.

(DP-306726 – DE3-0275) Application U.S.S.N. 60/375,787, "Method for Modeling Complex, Three Dimensional Tool Paths Through a Workpiece", filed April 26, 2002 by Steven Thomas et al.

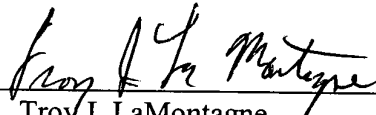
By such disclosure, Applicant does not waive and has no intent to waive any statutory right to maintain the secrecy of the above-referenced applications.

Applicant believes there is no fee associate with this Letter. However, if there are any additional charges with respect to this Letter or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicant's attorneys.

Respectfully submitted,

DIANE M. LANDERS, ET AL.

CANTOR COLBURN LLP
Applicant's Attorneys

By 
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Diane M. Landers et al.

Docket No.

DP-306553

Serial No.

10/002,678

Filing Date

10/24/2001

Examiner

NYA

Group Art Unit

NYA

Invention: **HORIZONTALLY STRUCTURED MANUFACTURING PROCESS MODELING FOR
FIXTURES AND TOOLING**

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I hereby certify that this CO-PENDING APPLICATION LETTER

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

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Jessica L. Walsh

(Typed or Printed Name of Person Mailing Correspondence)

A handwritten signature of Jessica L. Walsh in cursive script.

(Signature of Person Mailing Correspondence)

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2400

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): **DIANE M. LANDERS ET AL.**

Docket No.

DP-306553

Serial No.
10/002,678

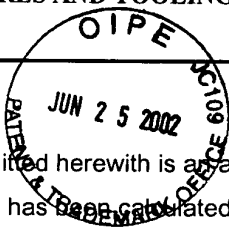
Filing Date
10/24/2001

Examiner
NYA

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Invention: **HORIZONTALLY-STRUCTURED MANUFACTURING PROCESS MODELING FOR
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TO THE ASSISTANT COMMISSIONER FOR PATENTS:

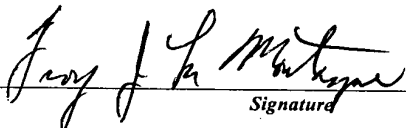
Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	44 -	44 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	4 -	4 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of _____ to cover the filing fee is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. **06-1130**
A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☐ Any patent application processing fees under 37 CFR 1.17.

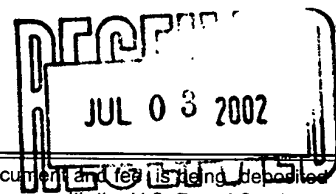

Signature

Dated: **June 20, 2002**

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20231.


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Jessica L. Walsh

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